I claim:

- A semiconductor chip carrier comprising: a primary substrate;
- 5 a metal heat sink plate having a first side and an opposing second side where said primary substrate is attached to said first side; and

a supplemental substrate attached to said metal heat sink plate on said second side.

- 10 2. A semiconductor chip carrier according to claim 1, wherein said supplemental substrate is constructed from a material having substantially similar coefficient of thermal expansion as said primary substrate.
- A semiconductor chip carrier according to claim 1, wherein said
 supplemental substrate is constructed from a same material as said primary substrate.
 - 4. A semiconductor chip carrier according to claim 1, wherein said primary substrate is constructed from a material selected from one of Bis-malesimide triazine epoxy, FR4, polyimide, and polytetrafluoroethylene.
 - A semiconductor chip carrier according to claim 1, wherein said primary substrate is a ball-grid array chip carrier.
- A semiconductor chip carrier according to claim 1, wherein said metal heat
 sink plate is a metal selected from one of Cu, Cu-W, Al and alloys thereof.
 - 7. A semiconductor chip carrier according to claim 1, wherein said supplemental substrate has a Cu-Ni finish layer.
- 30 8. A semiconductor chip carrier according to claim 1, wherein said supplemental substrate has a cavity exposing a portion of said metal heat sink plate.
 - A semiconductor chip carrier comprising:
 a primary substrate;

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a metal heat sink plate having a first side and an opposing second side where said primary substrate is attached to said first side; and

a supplemental substrate being attached to said second side of said metal heat sink plate, wherein said supplemental substrate is constructed from a material having a substantially similar coefficient of thermal expansion as said primary substrate.

- A semiconductor chip carrier according to claim 9, wherein said supplemental substrate is constructed from a same material as said primary substrate.
- 10 11. A semiconductor chip carrier according to claim 9, wherein said primary substrate is constructed from a material selected from one of Bis-malesimide triazine epoxy, FR4, polyimide, and polytetrafluoroethylene.
- A semiconductor chip carrier according to claim 9, wherein said chip carrier
 is a ball-grid array chip carrier.
 - A semiconductor chip carrier according to claim 9, wherein said metal heat sink plate consists of a metal selected from one of Cu, Cu-W, Al, and alloys thereof.
- 20 14. A semiconductor chip carrier according to claim 9, wherein said supplemental substrate has a Cu-Ni finish layer.
 - 15. A semiconductor chip carrier according to claim 9, wherein said supplemental substrate has a cavity exposing a portion of said metal heat sink plate.
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- 16. A method of forming a semiconductor chip carrier, comprising: providing a metal heat sink plate having a first side and an opposing second side;
- attaching a primary substrate to said first side; and

 30 attaching a supplemental substrate to said second side of said metal heat sink
 plate, wherein said supplemental substrate is constructed from a material having
 substantially similar coefficient of thermal expansion as said primary substrate.
- A process according to claim 16, wherein said supplemental substrate is
 constructed from a same material as said primary substrate.

- 18. A process according to claim 16, wherein said primary substrate is constructed from a material selected from one of Bis-malesimide triazine epoxy, FR4, polyimide, and polytetrafluoroethylene.
- A process according to claim 16, wherein said chip carrier is a ball-grid array chip carrier.

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